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REPLY UNDER 37 C.F.R. §1.116
EXPEDITED PROCEDURE REQUESTED

J. M. Miller
PATENT
465-758P
9/24/02

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IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Jun S. LEE / Conf.: 5244
Serial No.: 09/722,583 / Art Unit: 2823
Filed: November 28, 2000 / Examiner: B. Kebede
For: METHOD FOR FABRICATING CAPACITOR OF
SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. §1.116

Assistant Commissioner for Patents
Washington, DC 20231

September 19, 2002

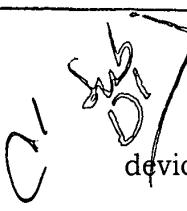
Sir:

In response to the Office Action mailed July 11, 2002 (Paper No. 9), the following amendments and remarks are respectfully submitted in connection with the above-identified application:

IN THE CLAIMS:

Please **cancel claims 3 and 6** without prejudice or disclaimer.

Please **amend claims 1, 3, 4, and 6** as follows:



1. (Amended) A method for fabricating a capacitor of a semiconductor device comprising: